



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

RESPONSE TO OFFICE ACTION

MAILED APRIL 6, 2005

Atty. Docket No. (Opt.)
UBAT1360-2

Applicants: **Michael A. Guillorn, et al.**

Application Number
10/681,565

Filed
October 8, 2003

For:
**Gated Fabrication of Nanostructure Field
Emission Cathode Material Within a Device**

Group Art Unit
2812

Confirmation Number:
9447

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Certification Under 37 C.F.R. §1.10

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express Mail Post Office to Addressee in an envelope bearing Express Mail mailing label number **ED 507064389 US** addressed to: Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450 on August 8, 2005.


John J. Bruckner

IN THE TITLE

Please change the title to:

NANOSTRUCTURE FIELD EMISSION CATHODE MATERIAL WITHIN A DEVICE